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PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hiroaki Miura;  
Hidekazu Takahashi;  
Yuichiro Okada

Confirmation No. Unknown

Serial No.: 10/572,858

Filed: October 27, 2005 Customer No.: 28863

Examiner: Unknown

Group Art Unit: Unknown

Docket No.: 1085-016US01

Title: LIGHT-CONTROL ELEMENTS AND MATERIALS

CERTIFICATE UNDER 37 CFR 1.8: I hereby certify that this correspondence is being deposited with the United States Post Service, as First Class Mail, in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 on

April 27, 2006

By:

Name: Connie Scheff

*Connie M. Scheff*

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendments  
Commissioner for Patents  
Alexandria, VA 22313-1450

Dear Sir:

Applicant submits the references listed on the attached form PTO-1449. This statement is being filed within three months of the filing date of the application.

Applicant has enclosed a copy of each article cited and each foreign document cited. Copies of the U.S. patents are not enclosed as this requirement has been waived by the U.S. Patent Office.

Respectfully submitted,

Date: April 26, 2006

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<b>Form 1449*</b>  <b>INFORMATION DISCLOSURE STATEMENT</b> <b>IN AN APPLICATION</b> (Use several sheets if necessary)		Docket Number: 1085-016US01		Application Number: 10/572,858	
		Applicant: Hiroaki Miura; Hidekazu Takahashi; Yuichiro Okada			
		Filing Date: October 27, 2005		Group Art Unit: Unknown	
		Examiner Name: Unknown			
<b>U.S. PATENT DOCUMENTS</b>					
<b>Examiner Initial</b>	<b>Document Number</b>	<b>Issue/Document Publication Date</b>	<b>Name</b>	<b>Filing Date If Appropriate</b>	
	2005/0140917	06/30/2005	Miura et al.		
<b>FOREIGN PATENT DOCUMENTS</b>					
<b>Examiner Initial</b>	<b>Document Number</b>	<b>Publication Date</b>	<b>Country</b>	<b>Translation</b>	
				<b>Yes</b>	<b>No</b>
	58-501631	09/29/1983	Japan	Abstract	
	61-502128	09/25/1986	Japan	Abstract	
	196 44 913	04/30/1998	Germany	Abstract	
<b>OTHER DOCUMENTS (Including Authors, Title of Item, Page(s), Vol/Issue No., Publisher, Place of Publication)</b>					
	Notification of Transmittal of the International Search Report and the Written Opinion of the International Searching Authority dated March 16, 2006, for corresponding International Application No. PCT/IB2005/003212, 13 pages.				
	Yoshihiko Hirai et al., "Application of Nano-Imprint Lithography," Journal of Photopolymer Science and Technology, Vol. 15, Number 3, 2002, pages 475-480.				
<b>EXAMINER</b>			<b>Date Considered</b>		
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.					

Based on Form PTO-FB-A820  
(Also form PTO-1449)

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